



AMENDMENTS OF CLAIMS
compliant with 37 CFR 1.121 (changed 7/3/03)

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Three pages. Claim 14 is currently amended.

1. (original) In a process for producing a product using a material which is electrochemically loaded with second material, a method of monitoring the loading within said material that comprises:
loading said second material,
mechanically coupling said material so as to enable a mechanical vibration of said material,
providing means to drive said vibration, and
providing means to follow the frequency of said vibration.
2. (original) A process as in claim 1 wherein the frequency of said vibration is followed by the material producing interference with an optical beam.
3. (original) A process as in claim 1 wherein said material is a member of the group consisting of palladium and palladium alloys.
4. (original) A process as in claim 1 wherein said second material is a member of the group consisting of deuterium or deuterons.
5. (original) A process as in claim 1 wherein said means to provide drive of said vibration comprises coupling said material to a second mass located external to said material.
6. (original) A process as in claim 5 wherein said second mass is an electromechanical device capable of a vibration.
7. (original) A process as in claim 1, where the material is loaded as an electrochemical cathode.

8. (original) In a process for loading a material with a second material, a method of monitoring the loading within said material that comprises:
loading said second material,
mechanically coupling said material so as to enable a mechanical vibrations of said material,
providing means to produce said vibrations,
providing means to detect the frequency of said vibrations.
9. (original) A process as in claim 8, where the material is loaded electrochemically.
10. (original) A process as in claim 8 wherein the frequency of said vibration is followed by the material producing interference with an optical beam.
11. (original) A process as in claim 8 wherein said material is a member of the group consisting of palladium and palladium alloys.
12. (original) A process as in claim 8 wherein said second material is a member of the group consisting of deuterium or deuterons.
13. (original) A process as in claim 8 wherein said means to drive said vibration is provided by additional coupling also to a longitudinal mass capable of providing restoring force along its length,
14. (currently amended) A process as in claim 8 wherein said means to drive said vibration comprises coupling said loaded material as a first mass to a second mass located external to said material.
15. (original) A process as in claim 14 wherein said second mass is capable of having at least one vibrational frequency.

16. (original) A process as in claim 14 wherein said second mass is driven by an electromechanical device.

17. (original) An apparatus to monitor the loading of a material by a second material which includes in combination:

- means to load said second material,
- means to enable mechanical vibrations of said material by mechanically coupling said material,
- means to drive said vibrations,
- means to detect the frequency of said vibrations.

18. (original) An apparatus as in claim 17 wherein said material is a member of the group consisting of palladium and palladium alloys.

19. (original) An apparatus as in claim 17 wherein said second material is a member of the group consisting of deuterium or deuterons.

20. (original) An apparatus as in claim 17 wherein said means to load said second material in the material is electrochemical.